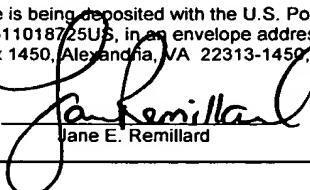


I hereby certify that this correspondence is being deposited with the U.S. Postal Service as Express Mail, Airbill No. EV311018725US, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: December 18, 2003 Signature: 
Jane E. Remillard

Docket No.: NAI-002
(Formerly 81206-243306)
(PATENT)



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Dan KALAS *et al.*

Application No.: 09/880,190

Art Unit: 2881

Filed: June 12, 2001

Examiner: P. M. Gurzo

For: **THIN RADIATION SOURCE AND METHOD
OF MAKING THE SAME**

RESPONSE TO NON-FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated June 18, 2003 (Paper No. 6), Applicants submit the following remarks in support of allowance of the above-identified U.S. patent application. Also submitted herewith is a Request and fee for the appropriate extension of time.

Remarks/Arguments begin on page 2 of this paper.